Ohmic transition at contacts key to maximizing fill factor and performance of organic solar cells

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Supplementary Information

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Supplementary Figure 1

Supplementary Figure 1. Valence band spectrum of PEDT: PSSCs*x***H1−***^x* **films. (a)** Valence band spectrum, plotted against binding energy (BE) relative to vacuum level (VL) for film Arrows indicate peak positions determined from second-derivative spectrum. **(b)** Second-derivative spectrum, obtained by digital derivatization of the spectrum in (a) with appropriate smoothing. Spectral assignments are marked. Phenyl refers to the localized phenyl MO of PSS; sulfur refers to the localized (lone-pair) sulfur MO of PEDT. Molecular H_2O is bound to the $-SO_3^-...Cs^+$ ion clusters, but not $-SO₃H$. The constant energies of these features reveal the absence of any contribution from a varying surface-dipole layer to the work function shift. Assignments are

Supplementary Table 1

Supplementary Table 1. Device parameter set employed for simulation of bulk *JV* characteristics for PEDT: PSSCs_xH_{1-x}/ P3HT: PCBM/ Ca solar cells. The parameters have been validated in crosslinked donor polymer network: fullerene solar cells with well controlled donor−acceptor morphology over wide thickness range.³ P_p is a variable scaled by ($\phi - \phi_{\text{pin}}$).

Supplementary Note 1: Fermi-Level Pinning and Effective Work Function

We use ϕ to denote the vacuum work function of the electrode, in this case PEDT: PSS(Cs_xH_{1-x}), which is the energy difference between its Fermi level (FL) and the outside vacuum level (VL). This can be measured, for example by ultraviolet photoemission spectroscopy (UPS). $4-6$ We denote the effective work function of the electrode in contact with the semiconductor by ϕ_{eff} , which is the energy difference between FL of the electrode and the effective VL of the bulk of the semiconductor.⁷ The effective VL is what pertains when the semiconductor is notionally split to create a vacuum interface but without creating a dipole layer at the vacuum interface. ϕ_{eff} rather than ϕ is the quantity that is relevant to energy-level alignment in devices. It can be inferred from V_{bi} measurements in diodes, assuming ϕ_{eff} at one of the contacts is known *a priori*, for example through systematic correlation.⁷ Surveys of polymer organic semiconductor diodes suggest that ϕ_{eff} is a well-defined and portable under some conditions, in particular in the absence of Fermi-level (FL) pinning.⁷ When ϕ exceeds the work function for the onset of FL pinning ϕ_{pin} , charge transfer to the semiconductor band edge occurs, which opens a VL offset that greatly slows down the creep of FL up the density-of-states of the semiconductor. $8,9$ As a consequence ϕ_{eff} appears to be pinned at ϕ_{pin} . The location of ϕ_{pin} can thus be obtained from the interpolated knee in the plot of ϕ_{eff} against ϕ . The resultant accumulation of carrier density in an ultrathin layer with diffused tail at the semiconductor side of the contact, which we refer to variously as the 'δ-doped layer' or 'δ-density', can be measured and quantified by subgap electroabsorption spectroscopy.10

Supplementary Note 2: Fermi-Level Pinning Calculations

Calculations were performed at 290 K with the following parameters:

Footnotes:

^a We used a ε_r lower than 3 because of the absence of the conjugated polymer in the local ion cluster.

In a typical calculation, a certain density-of-states (DOS) function for the semiconductor is assumed. Then for each assumed effective work function of the hole contact ϕ_{eff} given by the work function for the semiconductor, we computed the vacuum-level offset at the contact $\Delta\phi_{\text{dl}}$ and the associated work function of the electrode ϕ , according to: $\phi = \phi_{\text{eff}} + \Delta \phi_{\text{dl}}$. $\Delta \phi_{\text{dl}}$ is given by the voltage drop associated with the double-layer capacitance due to the accumulated hole density and its image, which in the zero-K limit is given by: Δ $\phi_{\sf dl} = \frac{e\sigma}{c_{\sf dl}}$, where σ is the accumulated hole density given by $\sigma = \int_{\epsilon_F}^{\infty} N_i(\epsilon_i)(1-f_i(\epsilon_i))d\epsilon_i$, where $N_i(\epsilon_i)$ is the DOS and $f_i(\epsilon_i)$ is the Fermi-Dirac function, and *C*_{dl} is the double-layer capacitance given by $C_{\text{d}} = \frac{\varepsilon_0 \varepsilon_f}{d}$, where ε_0 is the vacuum permittivity, *ε*^r is the local dielectric constant, and *d* is the effective double-layer thickness. For an interface with a perfect conductor, *d* is given by half the distance to the image charge. We have checked that a variation in Δ ϕ _{dl} by up to a factor of three, due to uncertainty in *C*_{dl}, does not change the form of the plots. The FL pinning onset work function ϕ_{pin} is established from the kink in the ϕ_{eff} *vs* ϕ plot. This was computationally obtained by intersecting the unity-slope

straight line in the $\phi < \phi_{pin}$ regime, with a straight line fitted over ϕ_{pin} + 0.1 < $\phi < \phi_{pin}$ + 0.4 eV regime, following the usual experimental practice.

For a DOS with a hemi-gaussian frontier region with integrated hemi-gaussian DOS of 4 x 10^{13} cm⁻², our simulation gives $\phi_{\text{pin}} \approx (2.35 \pm 0.02) * \sigma_{G}$, where σ_{G} is the gaussian (standard deviation) width. For comparison, the ionization energy *I*_E conventionally defined by extrapolated onset of the highest-occupied molecular orbital (HOMO) band edge is at 2.00 $* \sigma_{G}$. Therefore in the absence of polarization-induced band-bending, Fermi-level pinning is expected to occur very close to the conventionally-defined band edge, at *ca*. 0.35 $*$ σ_G into the gap from the band edge. This amounts to 63 meV for a typical σ _G of 0.18 eV. Furthermore, we found for σ _G of 0.18 eV that contact resistivity scales as: $\rho_c \sim \sigma^{-0.82}$ for ϕ in the range of $\phi_{\text{pin}} \pm 0.2$ eV.

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